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Bib Data Sheet

CONFIRMATION NO. 1106

SERIAL NUMBER 10/563,115	FILING OR 371(c) DATE 01/03/2006 RULE	CLASS 117	GROUP ART UNIT 1722	ATTORNEY DOCKET NO. 03500.109446
APPLICANTS Masaki Mizutani, Tokyo, JAPAN; Shoji Nishida, Tokyo, JAPAN; Katsumi Nakagawa, Tokyo, JAPAN;				
** CONTINUING DATA ***** This application is a 371 of PCT/JP05/09305 05/17/2005				
** FOREIGN APPLICATIONS ***** JAPAN 2004-156968 05/27/2004				
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 04/12/2006				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Acknowledged <i>[Signature]</i> Allowance Examiner's Signature <i>[Signature]</i> Initials <i>EH</i>		STATE OR COUNTRY JAPAN	SHEETS DRAWING 2	TOTAL CLAIMS 4
INDEPENDENT CLAIMS 2				
ADDRESS 5514				
TITLE Silicon layer production method and solar cell production method				
FILING FEE RECEIVED 900	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	